



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 8859

SERIAL NUMBER 10/585,994	FILING or 371(c) DATE 07/13/2006 RULE	CLASS 400 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. 33082M336		
APPLICANTS Yasuo Kobayashi, Yamanashi-Ken, JAPAN; Kenichi Nishizawa, Kumamoto-ken, JAPAN; /K.P./ Takatoshi Kameshima, Yamanashi-ken, JAPAN; Takaaki Matsuoka, Tokyo-To, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP2005/000297 01/13/2005 /K.P./ ** FOREIGN APPLICATIONS ***** JAPAN 2004-005738 01/13/2004 JAPAN 2004-290846 10/01/2004 /K.P./ ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/02/2008						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/KEVIN A PAREDO/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 9	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 4
ADDRESS SMITH, GAMBRELL & RUSSELL 1130 CONNECTICUT AVENUE, N.W., SUITE 1130 WASHINGTON, DC 20036 UNITED STATES						
TITLE Manufacturing Method Of Semiconductor Device And Film Deposition System						
FILING FEE RECEIVED 1100	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		